



Docket No.: 243579US0X



COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

RE: Application Serial No.: 10/677,309

Applicants: Tetsuo SUZUKI, et al.

Filing Date: October 3, 2003

For: METHOD OF RECLAIMING SILICON WAFERS

Group Art Unit: 1763

Examiner: ARANCIBIA, M.

SIR:

Attached hereto for filing are the following papers:

RESPONSE AND REQUEST FOR RECONSIDERATION

Our check in the amount of \$0.00 is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

TETSUO SUZUKI, ET AL. : EXAMINER: ARANCIBIA, M.

SERIAL NO: 10/677,309 :

FILED: OCTOBER 3, 2003 : GROUP ART UNIT: 1763

FOR: METHOD OF RECLAIMING
SILICON WAFERS :

RESPONSE AND REQUEST FOR RECONSIDERATION

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated July 14, 2006, Applicants respectfully request reconsideration of the above-identified application in view of the following remarks:

Request for Reconsideration begins on page 2 of this paper.